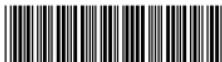


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10677309	SUZUKI ET AL.
Examiner	Art Unit	
Gramaglia, Maureen	1792	

SEARCHED

Class	Subclass	Date	Examiner
UPDATED	SEARCH	10/28/07	MGA
UPDATED	SEARCH	3/25/08	MGA
UPDATED	SEARCH	10/9/08	MGA
UPDATED	SEARCH	4/19/09	MG

SEARCH NOTES

Search Notes	Date	Examiner
UPDATED SEARCH	10/28/07	MGA
UPDATED SEARCH	3/25/08	MGA
UPDATED SEARCH	10/9/08	MGA
Google Patents search: "silicon wafer etch then clean with mixture of hydrofluoric acid and hydrogen peroxide"	10/9/08	MGA
UPDATED SEARCH	4/19/09	MG

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner